

Application No. 10/568,727

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Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 100191CIP)

First Inventor: Schroeder, David

Serial No.: 10/568,727

Filing Date: 02/17/2006

Title: CHEMICAL-MECHANICAL
POLISHING COMPOSITION AND
METHOD FOR USING THE
SAME

Examiner: Vinh. Lan

Art Unit: 1792

Certificate of Facsimile Transmission

I, Mary Anderson, hereby certify that this paper and enclosure(s), if any, are hereby being transmitted by facsimile to the US Patent and Trademark Office's central fax No. (571) 273-8300 on MAR. 19, 2010.

Mary Anderson
(Sender's signature)

RESPONSE TO OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir,

This paper is submitted in response to the Office Action mailed January 22, 2010. Please consider the following remarks and enter the following amendments in the record for this application.

The listing of claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.